

Electronic Acknowledgement Receipt

EFS ID:	1209757
Application Number:	10567729
Confirmation Number:	7682
Title of Invention:	Silicon carbide epitaxial wafer, method for producing such wafer, and semiconductor device formed on such wafer
First Named Inventor:	Kazutoshi Kojima
Customer Number:	270
Filer:	William Bak
Filer Authorized By:	
Attorney Docket Number:	OGOSH46USA
Receipt Date:	20-SEP-2006
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Application Type:	U.S. National Stage under 35 USC 371
International Application Number:	

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Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1		Response.pdf	76683	yes	3

	Multipart Description		
	Doc Desc	Start	End
	Supplemental Response or Supplemental Amendment	1	1
	Specification	2	2
	Applicant Arguments/Remarks Made in an Amendment	3	3

Warnings:	
Information:	
Total Files Size (in bytes):	76683

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New Applications Under 35 U.S.C. 111
If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371
If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.